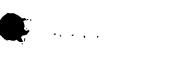
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GRCUP 1700

PATENT APPLICATION

MAR 1 3 2003 5

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)		
		:	Examiner:	Thi D. Dang
TOSHIYASU SHIRASUNA ET AL.)		•
		:	Group Art	Unit: 1763
Application No.: 09/899,188)		
		:		
Filed: July 6, 2001)		•
		:		
For:	PLASMA TREATMENT,)		
	METHOD AND PLASMA	:		
	TREATMENT APPARATUS)	March 12,	2003

Commissioner for Patents Washington, D.C. 20231

AMENDMENT

Sir:

a) <u>Introductory Comments</u>

This Amendment is filed in accordance with the OG.Notice-1267 Off..Gaz

Pat.Office 106 of February 25, 2003 in which 37 C.F.R. §1.121(a)-(d) is waived for

amendments to the application where the Amendment complies with the Revised

Amendment Format of the OG Notice.

In response to the outstanding Office Action mailed December 13, 2002, please amend the subject application as follows: